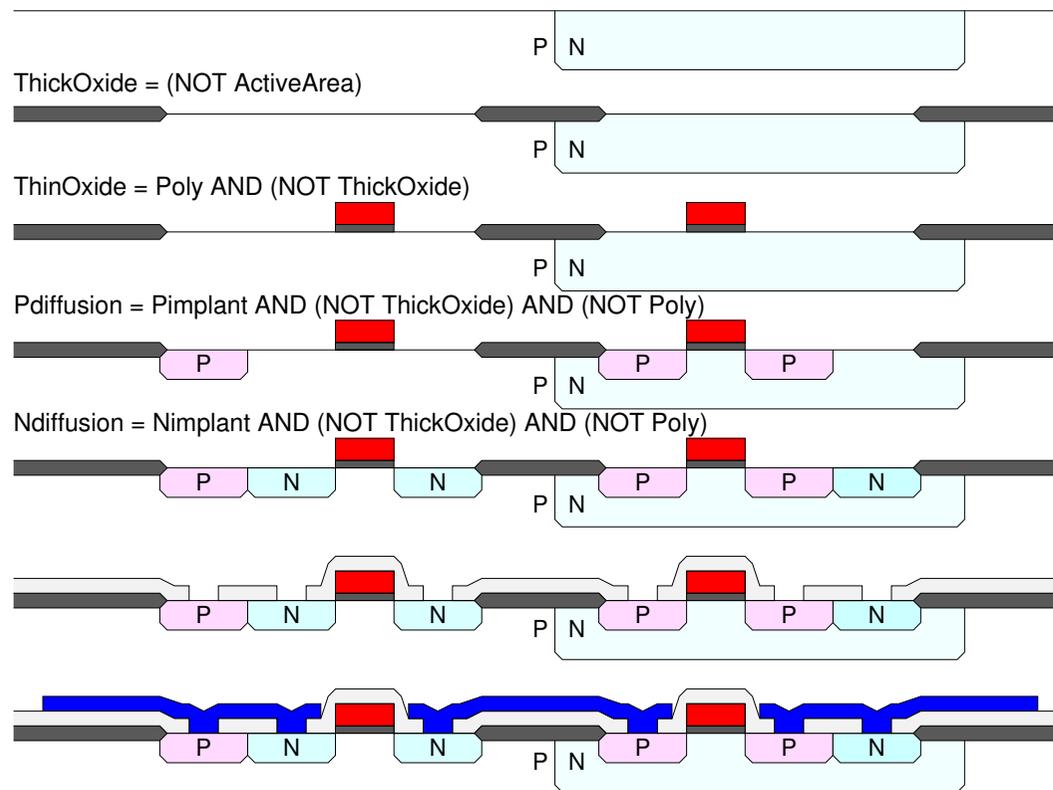
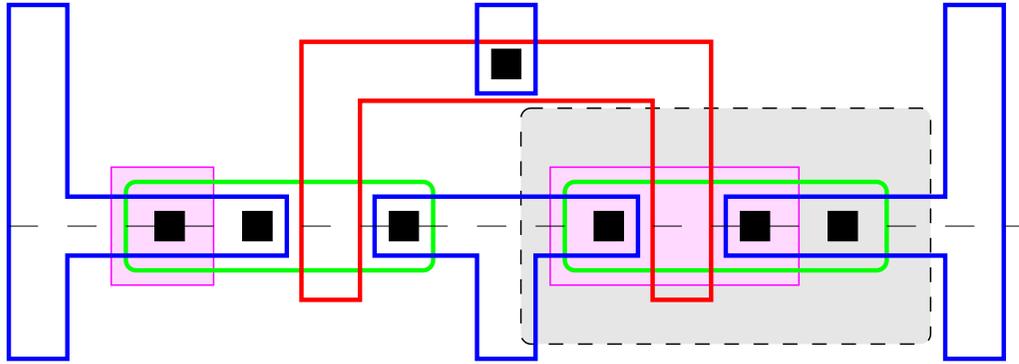
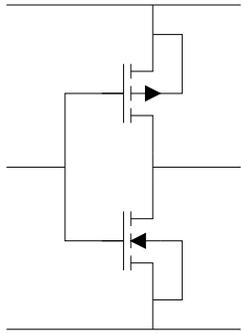


-  N-well
-  Active Area
defines Thick Oxide
-  Polysilicon
defines Thin Oxide
-  P implant
aligned to AA and Poly
defines P diffusion
-  N implant
aligned to AA and Poly
defines N diffusion
-  Contact Window
-  Metal





■ N-well

○ Active Area
defines Thick Oxide

□ Polysilicon
defines Thin Oxide

□ P implant
aligned to AA and Poly
defines P diffusion

□ NOT P implant
aligned to AA and Poly
defines N diffusion

■ Contact Window

□ Metal

